



SHEET 1 OF 1

Form PTO 1449
(Modified)U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICEATTY DOCKET NO.
240474US6YASERIAL NO.
10/811,932

LIST OF REFERENCES CITED BY APPLICANT

APPLICANT
Hongyu YUE, et al.FILING DATE
March 30, 2004GROUP
2857

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
	AM						
	AN						

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION	
					YES	NO
	AO					
	AP					
	AQ					
	AR					
	AS					
	AT					
	AU					
	AV					

OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)

ED	AW	Nital S. PATEL, et al., "Adaptive Optimization of Run-to-Run Controllers: The EWMA Example", IEEE Transactions on Semiconductor Engineering, vol. 13, no. 1, February 2000, pages 97-107				
ED	AX	P. K. MOZUMDER, et al., "A Monitor Wafer Based Controller for Semiconductor Processes", IEEE Transactions on Semiconductor Manufacturing, vol. 7, no. 3, August 1994, pages 400-411				
	AY					
	AZ				<input type="checkbox"/> Additional References sheet(s) attached	

Examiner

Elias Desta

Date Considered

11/21/2005

*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.